



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

February 21, 2026	
IGI Report Number	LG770640045
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	OVAL BRILLIANT
Measurements	10.58 X 7.22 X 4.42 MM

GRADING RESULTS

Carat Weight	2.08 CARATS
Color Grade	F
Clarity Grade	VVS 2

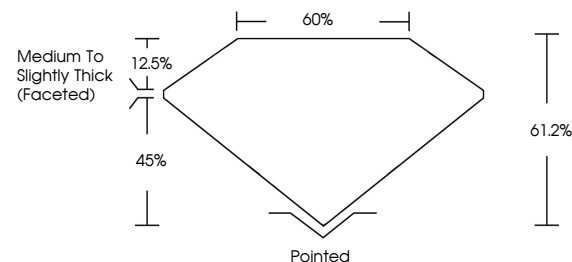
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	151 LG770640045

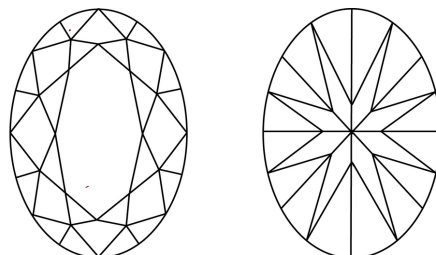
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG770640045
Report verification at lgi.org

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

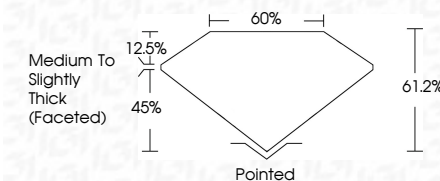
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www.igi.org

January 21, 2026	2.08 CARATS
GIA Report No. LG77040045	F
GYAL BRILLANT	VVS 2
	61.2%
	60%
	Medium to Slightly Thick (Faceted)
	Ported
	EXCELLENT
	EXCELLENT
	NONE
	ISS: LG77040045

Comments: This is a very poor diamond was created by Chemical Vapor Deposition (CVD) growth process.

Type IIA